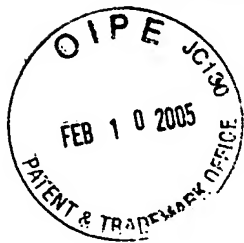


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Mark M. Abumeri
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February 7, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: Title: DEVICE AND METHOD OF CORRECTING EXPOSURE
DEFECTS IN PHOTOLITHOGRAPHY

Letters Patent No. 6,812,999 B2

Issued: November 2, 2004

Our Reference: MICRON.100C1

Certificate

FEB 24 2005

Dear Sir:

of Correction

Enclosed for filing is a Certificate of Correction in connection with the above-identified patent.

As the errors cited in the Certificate of Correction were incurred through the fault of the Patent Office, no fee is believed to be required. However, please charge our Deposit Account No. 11-1410 for any fees that may be incurred with this request.

Respectfully submitted,

Knobbe, Martens, Olson & Bear, LLP

Mark M. Abumeri
Registration No. 43,458
Customer No. 20,995

Enclosure

PA-014
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020205

FEB 28 2005

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UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 6,812,999 *B2*

DATED : November 2, 2004

INVENTOR(S): Hickman, Craig A.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Title Page

Item 63, **RELATED U.S. APPLICATION DATA**, please delete "now abandoned" and insert -- now
US Patent No. 6,727,975 --

MAILING ADDRESS OF SENDER:

Mark M. Abumeri
KNOBBE, MARTENS, OLSON & BEAR, LLP
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Irvine, California 92614

PATENT NO. 6,812,999

February 7, 2005

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